

Notice of References Cited

Application/Control No.

09/683,857

Applicant(s)/Patent Under
Reexamination
CHEN ET AL.

Examiner

David L. Hogans

Art Unit

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U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-----------------|----------------|
| | A | US-5,242,841 | 09-1993 | Smayling et al. | 438/275 |
| | B | US-5,519,247 | 05-1996 | Arbus et al. | 257/437 |
| | C | US-6,444,487 | 09-2002 | Boggs et al. | 438/48 |
| | D | US-6,130,458 | 10-2000 | Takagi et al. | 257/351 |
| | E | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|--|
| | U | Quirk et al., Semiconductor Manufacturing Technology (2001), Prentice Hall, pages 228, 229 and 348 |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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